

Search Notes

Application/Control No.

10/599,164

Examiner

Hau V. Phan

Applicant(s)/Patent under
Reexamination

VAN RHEENEN, REMCO

Art Unit

3618

SEARCHED

Class	Subclass	Date	Examiner
280	40 47.26 47.28 47.29	2/11/2008	HP
	47.27		
	654		
	659		
	47.131		
	43.1		
248	95	2/11/2008	HP
	98		
	99		

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR